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Low-Energy Sensitive Diodes for hCMOS Sensors

Q. Looker, R. Kay, J. Long, G. Robertson, M. Sanchez, D. Trotter, J. Porter

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Pulsed Power Applications Exist for Soft X-Ray and Electron Detectors



- Potential Applications
 - Thermometry on Z shots: soft x-rays 100-600 eV
 - Pulse dilation camera: electrons 2-10 keV
- Si Diodes Advantageous
 - Time-resolved measurements
 - Easily integrated into hCMOS camera
- Current Challenges
 - Current diodes insensitive to photons below ~700 eV
 - Low detection efficiency for electrons below about 10 keV

MagLIF Pre-Heating





Silicon Detector Construction Matters



- Detector electrodes sense moving charge
- Maximum signal generally requires complete charge collection
- Reduced charge collection from interactions near surface



Soft X-Ray Detection is a Shallow Issue

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- X-Rays 100-1000 eV
- Predominantly photoelectric absorption – energy too high for reflection, too low for Compton scatter
- Extremely short absorption length detector surface properties dominate
- Dead layer approximation





Electron Detection adds Backscatter to the Mix

- Electrons 1-10 keV
- Coulomb scattering continuous energy deposition
- Extremely short absorption depth – dead layer requirements similar to soft X-Ray
- Backscatter also important

$$\Delta_{bs} = \eta \, \frac{\overline{E_{out}}}{E_{in}}$$

 η : backscatter probability E_{in} : incident electron energy $\overline{E_{out}}$: average backscattered electron energy Δ_{bs} : backscatter deficit





Existing Technology

- OptoDiode AXUV models are a common standard
- Need for CMOS compatibility, high fill factor, and wafer real estate drove cameras to hybridization
- Sandia test photodiode utilizes similar technology to hCMOS cameras



REG10N

+ REGION

P + SUBSTRATE

Sandia

ALUMINUM

CHROMIUM-GOLD

DEFECT-FREE

N-TYPE REGION



6-100 µ

ACTIVE REGION DXIDE 3−7 pm

FIELD DXIDE

P-EP1 > 1 ohm/cm

Electron Sensitivity was Tested Using an SEM

- Responsivity is a general measure of diode sensitivity to a particular radiation type
- DC measurement is well-controlled

 $R = \frac{I_{diode}}{P_{beam}}$ R: diode responsivity $I_{diode}: diode photocurrent$ $P_{beam}: incident beam power$ $I_{beam}: incident beam current$ $E_{beam}: incident beam energy$

w: electron-hole pair

For Si, w=3.67±0.02 eV [1]

creation energy



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 $P_{beam} = I_{beam} * E_{beam}$

 $R_{ideal} = \frac{1}{w}$

Following [2], three major loss mechanisms:

$$R = R_{ideal} [1 - \Delta_{dl} - \Delta_{bs} - \Delta_{res}]$$

 Δ_{dl} : dead layer absorption Δ_{bs} : backscatter loss Δ_{res} : residual loss

[1] R. Pehl et al., NIM Vol. 59, pp. 44-55 (1968)[2] H. Funsten et al., IEEE TNS Vol. 44, No. 6, p. 2561 (1997)

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Method was Benchmarked using Industry Standard

- OptoDiode's AXUV100G is a widely used standard
- Model predicts dead layer and backscatter loss



[1] H. Funsten et al., IEEE TNS Vol. 44, No. 6, p. 2561 (1997)
[2] H. Hunger & L. Kuchler, Phys. Stat. Sol. Vol. 56, pp. K45-K48 (1979)
[3] J. Ashley & V. Anderson, JES Vol. 24, pp. 127-148 (1981)



Current Generation Diode Array Sensitivity Tested

 Surface passivation adds more dead layer absorption, but apparently reduces surface recombination





Dead Layer based on Si_3N_4 stopping power from [1] and SiO_2 stopping power values from [2]

[1] NIST Estar, http://physics.nist.gov/PhysRefData/Star/Text/ESTAR.html
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Path Forward

- hCMOS cameras will incorporate nitride passivation layer
- New discrete diodes will provide test bed for alternative technologies
 - JPL Delta Dope, successfully demonstrated to increase CCD UV sensitivity [1]
 - Univ. of Arizona flash oxide, also demonstrated for UV rays on CCDs [2]
- hCMOS diode arrays will incorporate new findings





[1] Hoenk et al., APL Vol. 61, pp. 1084-1086 (1992)[2] Janesick et al., Opt. Eng. Vol. 26, pp. 852-863 (1987)